

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yeo, *et al.* Docket No.: TSM03-0926  
Serial No.: 10/685,938 Art Unit: 2891  
Filed: October 15, 2003 Examiner: Movva, Amar  
For: Dummy Pattern for Silicide Gate Electrode

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed October 11, 2007. Please amend the above-referenced application as follows.